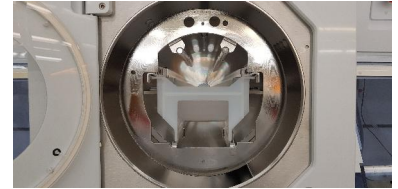


Sitek - SemiTool 870-S SRD

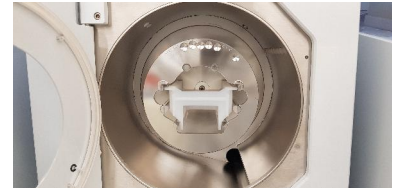
Overview

SemiTool 870-S double stack SRD. Top unit suitable for up to 150 mm substrates, bottom rotor suitable for 100mm, round substrates.

LMACS Name	Sitek 870-S SRD (top - 150 mm round) Sitek 870-S SRD (bottom - 100 mm round)
Confluence Label	sitek-semi-tool-870-s-srd
Process Area	WET PROCESSING
Model	SemiTool 870-S
Vendor	Sitek Process
Team	Michael Hume Adam Pettigrew Aaron Hryciw Stephanie Bozic



Top - 150mm Round



Bottom - 100mm Round

System Features

Top Rotor	150 mm (A190-60M-0215)
Bottom Rotor	100 mm (A190-40M-0215)
Nitrogen	N2 purge saver
Control	Sitek SlickDevice SI touch screen controller
Recipes	Up to 20 programmable recipes
Capacity	25 wafers

Key Documents

SOP & Hazard Assessment	Sitek SemiTool 870-S SOP & HA Listing
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Related Documents

Content by label

There is no content with the specified labels

